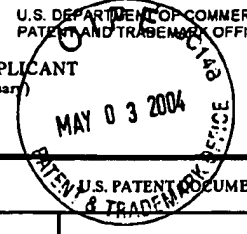


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE <div style="border: 1px solid black; border-radius: 50%; padding: 5px; display: inline-block; text-align: center;"> MAY 03 2004 RECEIVED </div>		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)						APPLICANT Weimin Li, et al.	
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PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<div style="font-size: 2em;">↓</div>	AA	6,503,818 B1	01/2003	Jang			
	AB	6,486,061 B1	11/2002	Xia et al.			
	AC	6,486,057 B1	11/2002	Yeh et al.			
	AD	6,465,372 B1	10/2002	Xia et al.			
	AE	6,444,593 B1	09/2002	Ngo et al.			
	AF	6,436,808 B1	08/2002	Ngo et al.			
	AG	6,435,943 B1	08/2002	Chang et al.			
	AH	6,429,115 B1	08/2002	Tsai et al.			
	AJ	6,284,677 B1	09/2001	Hsiao et al.			
	AJ	6,030,901	02/2000	Hopper et al.			
	AK	6,133,618	10/2000	Steiner			
	AL	5,994,217	11/1999	Ng			
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
<div style="font-size: 1.5em;">↓</div>	AM	8040186	02/1996	Japan			
	EK	AN	8046186	2/1996	Japan	X	
	AO	7201716	08/1995	Japan			
	EK	AP	7201716	08/1995	Japan	X	
	EK	AQ	8046188	02/1996	Japan		
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<div style="font-size: 1.5em;">↓</div>	AR		Wolf, S., Silicon Process., V.1 407-413.				
<div style="font-size: 1.5em;">↓</div>	AS		Wolf, S., Silicon Process., Vol 2 48-49 and 435.				
<div style="font-size: 1.5em;">↓</div>	AT		Wolf, S., Silicon Processing for the VLSI Era, Vol. 3, page 635.				
EXAMINER E-K				DATE CONSIDERED 6/8/2004			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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EK	AA	5,985,519	11/1999	Kakamu et al.		
	AB	5,747,388	05/1998	Kusters et al		
	AC	5,639,687	06/1997	Roman et al		
	AD	5,498,555	03/1996	Lin		
	AE	6,153,504	11/2000	Shields et al		
	AF	4,971,655	11/1990	Stefano et al		
	AG	6,498,084	12/2002	Bergemont		
	AH	5,036,383	07/1991	Mori		
	AI					
	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
EK	AM	6232113	08/1994	Japan				
	AN	8051058	02/1996	Japan				
	AO	63316476	12/1988	Japan				
	AP	8078322	03/1996	Japan				
	AQ	10-163083	06/1998	Japan				
	AR	08-045926A	02/1996	Japan				

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AS			
AT			

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